deposited with the United States Postal Service, with sufficient postage, as first class mail in an envelope addressed to:

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450, Alexandria, Virginia 22313-1450
on January 18, 2006

Date of Deposit

Jasper W. Dockrey, Reg. No. 33,868

Name of applicant, assignee or Registered Representative

> Signature January 18, 2006

Date of Signature

Our Case No. 10125/4017

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Hitoshi Seki et al.	) ) Examiner:
Serial No. 09/595,415	) Shamim Ahmed
Filing Date: June 16, 2000	)
For: ETCHING REAGENT, AND METHOD FOR MANUFACTURING ELECTRONIC DEVICE SUBSTRATE AND ELECTRONIC DEVICE	) Group Art Unit: ) 1765 )

## **AMENDMENT AND RESPONSE UNDER 37 CFR §1.111**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 18, 2005, in the above-referenced application, please reconsider the rejection in view of the amendment and remarks presented herein.

Applicants' amendments to the claims begin at page 2 of this paper.

The Applicants' remarks begin at page 5 of this paper.